



ITEN

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6560**  
Junji KUNISAWA et al. : Docket No. 2003\_1074  
Serial No. 10/629,678 : Group Art Unit 1746  
Filed July 30, 2003 : Examiner Joseph L. Perrin

HOLDING UNIT, PROCESSING APPARATUS  
AND HOLDING METHOD OF SUBSTRATES

**RESPONSE**

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the requirement contained in the Office Action mailed May 28, 2004, Applicants hereby elect invention II, claims 1 and 5-8, drawn to a processing apparatus.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

Junji KUNISAWA et al.

By: David M. Ovedovitz  
David M. Ovedovitz  
Registration No. 45,336  
Attorney for Applicants

DMO/jmj  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
June 14, 2004